

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79832

SHIBATO, Kishio, et al.

Continuation of Appln. No.: 10/111,132

Group Art Unit: 1712 (parent)

Confirmation No.: 8031 (parent)

Examiner: Jeffrey Robertson (parent)

Filed: February 24, 2004

For: STAIN RESISTANT COATING COMPOSITIONS, METHODS OF COATING AND  
COATED ARTICLES

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR §§ 1.97 and 1.98**


Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 CFR §1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form which are all the references of record in parent application No. 10/111,132. Applicant is not submitting duplicate copies of these references but requests that they be listed on the face of any patent granted on the above application. (See 37 CFR §1.98(d)). Copies of any cited copending applications, if not previously submitted, are being submitted herewith.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

Respectfully submitted,



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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: February 24, 2004

Substitute for Form 1449 A & B/PTO  <b><u>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</u></b>  <i>(use as many sheets as necessary)</i>				<i>Complete if Known</i>	
				Application Number	Unassigned
				Confirmation Number	8031 (parent)
				Filing Date	February 24, 2004
				First Named Inventor	SHIBATO, Kishio
				Art Unit	1712 (parent)
Examiner Name	Jeffrey Robertson (parent)				
Sheet	1	of	1	Attorney Docket Number	Q79832

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> (if known)		
		US 5,698,628		12-16-1997	Masuda et al.
		US 5,721,015		02-24-1998	Iwamura et al.
		US 6,103,387		08-15-2000	Yamamoto et al.
		US 20030045626		03-06-2003	Tamori et al.
		US			
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		US			
		US			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			
		EP	1 013 730	A1	06-28-2000	Nambu et al.	
		JP	11 116 847	A	04-27-1999	Nakamura et al.	
		JP	7 292 041	A	11-07-1995	Tamai et al.	
		JP	10 88065	A	04-07-1998	Nambu et al.	
		JP	7 173 429	A	07-11-1995	Tamai et al.	
		JP	6 145 453	A	05-24-1994	Kusumi et al.	
		EP	85 10 09	A2	07-01-1998	Gotch et al.	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>
		Machine Translation of JP 07-173429 A, 07-1995, Tamai et al., obtained from the JPO website.	
		Machine Translation of JP 07-292041 A, 11-1995, Tamai et al., obtained from the JPO website.	
		Machine Translation of JP 10-088065 A, 04-1998, Nambu et al., obtained from the JPO website.	
		Machine Translation of JP 11-116847 A, 04-1999, Nakamura et al., obtained from the JPO website.	

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kind Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov), MPEP 901.04 or in the comment box of this document. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to indicate here if English language Translation is attached.